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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kun-Hong LEE et al. Confirmation No.: 8793
Appl. No. : 10/522,572
Filed : January 28, 2005
Title : ELECTRIC FIELD EMISSION DEVICE HAVING A TRIODE
STRUCTURE FABRICATED BY USING ANODIC
OXIDATION PROCESS AND METHOD FOR FABRICATING
SAME

TC/A.U. : 2879
Examiner : K. J. Quarterman

Docket No.: : LEEK3013/REF
Customer No: : 23364

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to Rule 37 C.F.R. §§ 1.51(b), 1.56, 1.97 and 1.98, this Supplemental Information Disclosure Statement is being submitted with the references in the above-identified patent application. A listing of these documents is submitted herewith on Form PTO/SB/08A. The foreign and non-patented references are herewith enclosed.

This Information Disclosure Statement is after the mailing date of the first Official Action on the merits received by Applicants but before the mailing of any of a final action under §1.113, a notice of allowance under §1.311, or any action that otherwise closes the prosecution in the application.

Moreover, this Supplemental Information Disclosure Statement is also submitted in accordance with 37 C.F.R. §1.97(e) in that each item of information contained in the Supplemental Information Disclosure Statement was first cited in an Official Action of the corresponding Japanese Patent Application No. 2004-524373 on September 4, 2007 submitted herewith.

Appl. No.: 10/522,572
IDS dated: November 30, 2007

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Respectfully submitted,
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